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CONFIRMATION NO. 4154

SERIAL NUMBEI 09/927,444	FILING DATE 08/13/2001 RULE	CLASS ASS 00	GROUP ART UNIT	ATTORNEY DOCKET NO. 6217/Consilium/DV	
APPLICANTS Nicholas A. Ward, San Jose, CA; Richard Danielson, Pleasanton, CA; David B. Corey, Sandy, UT;					
** CONTINUING DATA **********************************					
Foreign Priority claimed 35 USC 119 (a-d) condition met Verified and Acknowledged	Allowance	er STATE OR COUNTRY	SHEETS TOTO CLA	IMS CLAIMS	
ADDRESS Patent Counsel, MS/2061 Legal Affairs Dept. Applied Materials, Inc. P.O. Box 450A Santa Clara, CA 95052					
TITLE Dynamic control of wafer processing paths in semiconductor manufacturing processes					
EN INC FEE FI	EES: Authority has been given in Paper b to charge/credit DEPOSIT ACCOUNT b for following:		All Fees 1.16 Fees 1.17 Fees time)	All Fees 1.16 Fees (Filling) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other	